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Tunable Bandgap in Silicene and	Độ rộng vùng cấm tùy chỉnh trong
Germanene checked 3/4	Silicene và Germanene
	Tunable: tùy chỉnh, thay đổi được
Supporting Information	Thông tin hỗ trơ
ABSTRACT: By using ab initio	TÓM TẮT: Thông qua việc sử dụng
calculations, we predict that a	tính toán ab initio (tính toán dựa trên
vertical electric field is able to open a	nguyên lý đầu) chúng tôi dự đoán
hand gap in semimetallic single-layer	rằng một trường dọc có thể mở vùng
buckled silicene and germanene. The	cấm trong silicene và germanene
sizes of the hand gap in both silicene	dang cong đơn lớn bán kim loại
and germanene increase linearly with	Kích thước của độ rộng vùng cấm
the electric field strength Ab initio	trong cå silicene và germanene tăng
quantum transport simulation of a	tuyến tính theo cường đô điện
dual-gated silicene field effect	trường Mô phỏng vận chuyển lượng
transistor confirms that the vertical	từ Ah initio của transistor hiệu ứng
electric field opens a transport gap	triràng hằng vật liêu silicene hại
and a significant switching effect by	cổng khẳng định rằng trường điện
an applied gate voltage is also	doc mở ra một khe vận chuyển và
observed Therefore biased single-	chúng tôi cũng đã quan sát được hiệu
lavar silicana and garmanana can	tring chuyển mạch rõ nát khi án vào
work effectively at room temperature	một điện án cổng Do đó, silicene và
as field effect transistors	germanene đơn lớp phân cực có thể
as new effect transistors.	boat động biệu quả ở nhiệt độ phòng
	nhự các transistor hiệu ứng trường
Graphana has attracted graat interast	lind cae transistor mçu ding truong .
recently for its exceptional electronic	
properties 1 -4 For instance its	
charge carriers are massless Dirac	
fermions leading to a mobility up to	
15 000 cm ² V-1 s-1 for graphene on	
SiO2 substrate and 200 000 cm ² V-1	
s-1 for suspended sample 1-4	
However the promising application	
of graphene in present electronic	
devices like field effect transistor	
(FET), still relies on the opening and	
controlling of the band gan	
Although a band gap is opened in	
bilayer and multilayer graphene	
under an external vertical electric	
field due to the inversion symmetry	
breaking,5 9 monolaver graphene	
remains zero-gap semimetallic	

equivalent under an external vertical electric field. Consequently, biased monolayer graphene cannot be operated effectively as a FET at room temperature. Other group IV elements. such as silicon and also germanium. have stable honeycomb monolayers (namely germanene).10'11 silicene and Synthesis of pristine, 12 Mg-doped13 and hydrogenated14 silicene, and pristine silicene nanoribbon15 have been reported. Unlike planar graphene monolayers, the most stable silicene and germanene monolayers prefer a low-buckled (silicene (LB)structure and referred to in the germanene following those with LB are structure). The electronic structures of the silicene and germanene are quite similar to that of graphene.10'11 Namely, silicene and germanene are zero-gap semimetallic. and their charge carriers are also massless fermions because their n and n* bands are linear at the Fermi level (Ef). When a vertical electric field is applied, the atoms in a buckled structure are no longer equivalent, and a band gap opening may become possible in silicene and germanene. If so, one can fabricate an FET operating at room temperature out of pure silicene and germanene.

In this Letter, we investigate the effects of a vertical electric field on silicene and germanene by means of the density functional theory (DFT) and the nonequilibrium Green's function (NEGF) method.

A band gap is unambiguously opened, and its size and the effective carrier mass increase linearly with the electric field strength. The effects of the vertical electric field on the transport properties of silicene are subsequently examined by fabricating a prototype of dual-gated silicene FET. A transport gap induced by perpendicular electric field is found, accompanied by significant switching effects by gate voltage.

Geometry optimization and electronic structure are calculated by all-electron double using an numerical atomic basis set plus polarization (DNP), as implemented in the Dmol3 package. A 32 X 32 X 1 Monkhorst-Pack17 k-points grid is used in the first Brillouin zone sampling. A vacuum space of 20 A is placed to avoid interaction between the monolayer and its periodic images. Both the atomic positions and lattice constant are relaxed. Transportation properties are calculated by the DFT coupled with NGEF formalism implemented in the ATK 11.2 package.18 20 Both single-Z (SZ) and double-Z plus polarization (DZP) basis sets are The k-points employed. of the electrodes and central region, which are generated by the Monkhorst-Pack scheme as well, are set to 1 X 300 X 300 and 1 X 300 X 1, respectively. The temperature is set to 300 K. The current is calculated by using the Landauer-Buttiker formula:21 where Tvg(E, Vbias) is the transmission probability at a given

gate voltage Vg and bias voltage





Vbias, fL/R the Fermi-Dirac

Figure 1. (a) Top and side view of silicene monolayer. The primitive cell is denoted by the red rhombus. The two equivalent atoms in silicene, labeled as A and B, respectively, have a corrugated arrangement. The structure of germanene is almost the same, except for a slightly larger lattice constant buckling and distance. (b) Buckling distance A of silicene and germanene as a function of calculated at the GGA/ DNP level. The left scale is for silicene, and the right one is for germanene.

Figure 2. Band structures of (a-c) silicene and (d-f) germanene around Ef at three different vertical electric fields calculated at the GGA/ DNP level. Inset in (a) and (d): Band structures in the first Brillouin zone at $E^{A} = 0$. The Fermi level or the valence band top is set to zero.

distribution function for the left (L)/right (R) electrode, and $^L/^R$ the electrochemical potential of the L/R electrode. Effects of gate are calculated by solving the Poisson equation self- consistently instead of simply lifting the central region's chem-ical potential. A generalized gradient approximation (GGA) to the exchange-correlation functional, of Perdew—Burke— Ernzerhof the (PBE) form,22 is used throughout this otherwise unless paper, specified.

Figure 3. (a) Band gap, (b) Mulliken charge transferred from one equivalent atom to the other, and (c) effective mass of electron at the conduction band bottom along the





KF and MK directions of silicene	
and germanene as a function of	
vertical electric field calculated at the	
GGA/ DNP level. The coupling	
coefficient of nearest neighbors in	
the TB model is set to 1.7 eV in	
silicene and 2.0 eV in germanene.	
The optimized electric field free	
silicene (shown in Figure 1a) and	
germanene at the GGA/DNP level	
have lattice constants of $a = 3.866$	
and 4.063 A. respectively. The	
corresponding buckling distances are	
A = 0.460 and 0.676 A, respectively.	
These structural parameters are in	
good agreement with previous	
works.10,11,23 As displayed in	
Figure 1b, the A value increases	
monotonically and nonlinearly with	
E^{A} after the application of a vertical	
electric field, with an increment of	
$3\%/0.2\%$ at $E \pm = 0.51$ V/A and	
$8\%/0.8\%$ at $E\pm = 1.03$ V/Ain	
silicene/germanene. The changes in	
the lattice constant a are less than	
0.2% in both silicene and germanene	
under $E \pm = 0 - 1.03$ V/A. Figure	
2a—f shows the band structures of	
silicene and germanene under three	
different electric field E [^] . Their	
conduction and valence bands touch	
linearly at the K point when $E \pm = 0$;	
thus, both silicene and germanene	
are semimetals with zero gap and	
zero effective mass. However, when	
finite E [^] is applied to silicene and	
germanene, a direct band gap is	
opened at the K point. The opened	
band gap is $Eg = 0.08/0.06$ eV for	
silicene/germanene under $E \pm = 0.51$	
V/A and doubled under $E^{-} = 1.03$	
V/A. The finer response of the band	
structure to $E\pm$ of silicene is	
provided in Figure S1, Supporting	

Information. As shown in Figure 3a, the opened band gap increases linearly with E[^] and surpasses the room temperature scale (0.026 eV) at $E \pm = 0.16$ V/A. The electric field required to open a gap of 0.16 eV in silicene and germanene is greater than that in bilayer and multilayer graphene by about an order of magnitude, but the band gaps in the latter increase nonlinearly with E^A and are saturated around $E^{\wedge} = 0.1$ V/A.7-9 Considering the sizable underestimation of the band gap in conventional DFT for a lowdimensional semiconductor, , the real band gaps in silicene and germanene should be significantly greater than the GGA/DNP ones. The MIN basis set yields a 4% larger lattice constant and 60-70% larger buckling (see Figure S2a, Supporting Information) than the DNP results and other theoretical values10,11,23 and thus unreliable in structural determination. However. the bandgap calculated with the MIN basis set based the DNP on (equivalent DZP) to optimized silicene structure is only 20% larger than those with the DNP basis set (see Figure S2b. Supporting Information). The linear dependence of Eg on $E\pm$ is well explained in terms of a tight binding (TB) model calculation (see Supporting Information), which gives $Eg = eE \pm A$, and the result is shown as the dashed lines in Figure 3a. The band gaps of the TB model

are several times larger than those of DFT because the screening effect is not taken into account in our TB model. Mulliken population analysis





displays a net charge transfer from one atom to the other in the primitive cells of silicene and germanene (shown in Figure 3b), and the amount of the polarized charge increases linearly with E±. Therefore and screening effect exists is enhanced with E±. According to the TB model, silicene has a smaller A and thus has a smaller Eg than germanene, while in the DFT calculation silicene has a larger Eg. Although the polarized charge in silicene is larger than that in germanene, it does not mean that silicene's screening is greater than germanene's, because Mulliken population analysis is rough and incapable of taking the charge's spatial distribution into account. In fact, bulk germanium has a larger dielectric constant (e = 16.0) and therefore more powerful screening effect than silicon (e = 11.9) does. In our self-consistent DFT calculation, the larger screening effect in germanium leads to a smaller band gap in germanene compared with silicene.

The variations of effective carrier masses of silicene and germanene along several directions in k-space under electric field are investigated by quadratic polynomial fitting of the conduction and valence bands (see Supporting Information). The effective masses of the conduction of silicene band bottom and germanene along the MK (meMK) and KT (meKr) are plotted in Figure 3c. The meMK values of silicene and germanene are larger than their respective meKr. All the four effective have masses an





hybridized silicene, the dielectric

should carefully be chosen. Experimentally, graphene has been deposited on an inactive hexagonal boron nitride (h-BN) multilayer, and the mobility of graphene is elevated by 1 order of magnitude compared with an SiO2 substrate-supported sample due to the smooth surface of h-BN.26,27 It is suggested that preservation of a high mobility in a dual-gated graphene device may be fabricating achieved by an h-BN/graphene/h-BN stack using a two-transfer technique.26 Theoretical investigation of hsandwich BN/graphene/h-BN structure shows that electrical fieldinduced bandgap opening in bilayer graphene is nearly unaffected by h-BN.28 Our simulation shows that silicene will spontaneously form covalent bonds with both Si and O atoms on the common SiO2 dielectric (Figure S3, Supporting Information). However, both silicene and h-BN are approximately intact when placed on or sandwiched between h-BN even under an electric field of up to 2 V/A. Total energy of silicene/h-BN system as a function of the distance between silicene and h-BN is provided in Figure S4. Supporting Information, with an equilibrium distance of 3.30 Α between silicene and h-BN. Figure 4a shows the sandwich structure under zero electric field. The buckling of silicene placed on (Figure S5, Supporting Information) or sandwiched between (Figure 4b) h-BN is also slightly enhanced by E^. The bandgap of silicene sandwiched between h-BN is even 50% larger than that of by

freestanding silicene under the same EJ (see Figure 4c). Therefore, insertion of h-BN buffer layer between silicene and oxide substrate is strongly recommended in a silicene FET device to maintain the structural integrity and high carrier mobility. In the dualgated silicene FET, silicene should be sandwiched between h-BN buffer layers. Our simulation shows that even single layer h-BN is nearly flat on SiO2 surface (Figure S6, Supporting Information) (multilayer h-BN is robust against buckling); more therefore the structure of silicene sandwiched between h-BN buffer layer can be maintained when placed on SiO2 dielectric.

The model of a dual-gated silicene FET with SiO2 dielectric and h-BN buffer layer is shown in Figure 5 a. Different from a single-gated FET, a dual-gated device can control not only the doping level but also the vertical electric field applied to the monolayer. The top and bottom gate voltages are labeled by Vt and Vb, respectively. The distance between the two gates is d0 = 20 A in our model, and the thickness of the both top and bottom dielectric plus buffer regions is di = 7 A. To avoid an insulator-to- metal transition in fewlayer h-BN caused by the Stark effect and to ensure the system can endure a strong electric field, the number of layers of buffer h-BN should be limited according to the DFT calculations.29,30 According to the DFT calculations, h-BN trilayer remains semiconducting under E_j = 0.829 or 1 V/A30 and can be used as buffer layer working under a strong



electric field up to 0.8-1 V/A, since h-BN trilayer probably can effectively tunneling prevent a between the gate and silicene. The dielectric constant of the dielectric and buffer regions is taken as e = 3.9. which models SiO2 and h-BN (e = 3-4). The vertical electric field applied to a silicene can be written as EJ =(Vt - Vb)/(d0 - 2di + 2di/e). The corresponding total gate voltage is Vg = Vt + Vb, reflecting the total doping level.

The transmission spectra of the device with a channel length of ^67 A under different Ej and Vg using an SZ basis set are displayed in Figure 5b, where the bias voltage is fixed at Vbias = 0.1V. As we know, the total conductance G(Ej, Vg) of an FET is proportional to the projected density of states (PDOS) of electrodes (denoted as Dl(Ej, Vg) for the left one and DR(E \pm > Vg) for the left one) and the channel cell (denoted as Dc(Ejl, Vg)):3^32

if the device is considered to be three resistors in series. Under Vbias = 0.1 V, the Dirac points of the source and drain in silicene FET move to ± 0.05 eV, respectively, regardless of EJ and Vg.

Under zero vertical electric field, there is a transmission "bulge" around Ef inside the bias window at Vg = -0.2 V for both the SZ (Figure 5b) and DZP (Figure S7, Supporting Information) basis sets. This is exactly as the case of graphene, 32 in which the relatively large transmission coefficients inside the bias window (i.e., the "bulge") lead relatively to a large current.







However, upon the application of EJ = 1 V/A on silicene, an obvious transport gap of about 0.14 eV is opened (Figure 5b) due to the occurrence of an about 0.12 eV pseudogap in DC(EJ, Vg) (Figure 5c) with an SZ basis set used, which apparently originates from the band gap of periodic silicene under the EJ. The channel same PDOS pseudogap and the transport gap can be shifted by Vg (Figure 5b, c and Figures S8 and S9, Supporting Information). Under Vg = 1V, both the two gaps are moved away from the bias window, resulting in the recovery of the bulge, and the device is turned from off- to on-state. Vg = -0.2 V is chosen to represent the offstate instead of Vg = 0 since the former case has smaller current. owing to the asymmetry of the transport gap around Ef. The difference in the off- and on-state is reflected from the transmission eigenchannel at Ef and at the (0, 1/3)point of k-space, as displayed in Figure 5d. The transmission eigenvalue of the off-state is 0.09, and the corresponding incoming wave function is apparently scattered and unable to reach to the other lead. On the contrary, the transmission eigenvalue of the on-state is 0.87, in which case the scattering is weak, and most of the incoming wave is able to reach to the other lead. The on/off current ratio under EJ =1V/Ais 4.2 with the SZ basis set at 300 K When a larger DZP basis set is used, a smaller pseudogap of about 0.1 eV in the transmission spectrum is opened under EJ = 1 V/A (Figure S7, Supporting Information), and the



semiconductor and that a quasiparticle correction (GW method) is required to obtain a reliable bandgap. Taking bulk Si as an example, the bandgap correction is increased by a factor of 150% upon quasiparticle correction. Such a bandgap correction is generally enhanced when dimensionality is reduced,24,36 and the bandgap correction in 2D silicene is expected to be greater (over 150%) than the correction in bulk silicon. The bandgap ofsilicene under EJ= 2 V/A is twice that under E J= 1 V/A and is chosen here as an approximation of the GW bandgap under EJ = 1 V/A. Compared the case with EJ=1 V/A, the PDOS and transmission spectra are further depressed near Ef at EJ= 2 V/A, as shown in Figures S7 and S8, Supporting Information. The DFT on/off ratio of a 67 A channel FET under EJ= 2 V/A is 50 with an SZ basis set, and the on/off ratio under EJ = 1 V/A is thus estimated to be 50 upon GW correction. By sharp contrast, the current change ratio is only 1.07 (DZP) ~ 1.12 (SZ) for silicene without a vertical electric field. Hence, a current switching effect induced by perpendicular electric field is well established in our dual-gated silicene FET model. Finally, we must point out that simply obtaining a large on/off ratio of silicene and graphene is not very difficult. For example, by cutting graphene into a nanoribbon, the on/off ratio can reach 106.37 However, one thing must be kept in mind that one of the most striking merits of silicene and graphene is their extraordinary high carrier

mobility, which is 1 -2 orders higher compared to a Si semiconductor and can lead to a quicker switching speed. It is a great challenge to simultaneously obtain high on/off ratio and keep ultrahigh carrier mobility in silicene and graphene, because the switching effect usually increases with the bandgap whereas the mobility usually decreases with the bandgap. The available methods to obtain a high on/offratio in graphene always lead to a drastic decrease in the carrier mobility by several orders of magnitude, totally losing the mobility advantage of graphene. If we want to maintain the extremely high carrier mobility of silicene and graphene, we have to compromise on the switching effect. Actually, as a feasible way to open a bandgap of bilayer graphene up to 0.25 eV7 without loss in carrier mobility. the measured roomtemperature on/off ratio in а vertically biased bilayer graphene FET is only increased by a factor of 25 than that of the unbiased one.38 In our work, the enhancement factor of vertically biased silicene with respect to the unbiased one is 8 (when the SZ basis set and a 130 A long channel are used) to 50 (with possible GW correction and 67 A long channel). Such enhancements are encouraging because the opened band- gap of silicene under an electric field of 1 V/A is only half the maximum bandgap (0.25 eV) of bilayer graphene opened by an electric field, and the extremely high mobility of silicene (w ~ 104-105cm2 V 1 s 1 in terms of our previous estimation of fl ~ 105cm2V 1s 1 at

Ej = 0.4 V/A and the relation of m* «Ej shown in Figure 3C and alsoderived in the SupportingInformation) is maintainedsimultaneously.In summary, our ab initio

calculations reveal one prominent advantage ofsilicene and germanene over graphene monolayers a monolayer. Namely, it is possible to open a bandgap in semi- metallic low-bulked silicene and germanene monolayers via an external vertical electric field, while it is impossible in a semi- metallic planar graphene The bandgap monolayer. and effective masses of both electrons and holes increase linearly with the electric field strength. An electrical field-induced transport gap is calculated in a simulated dual-gated silicene FET device, which enables us to switch the current of such a silicene-based device. Our work is expected to stimulate the experimental fabrication of FET out of pristine silicene and germanene monolayers.

